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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: NORIYA HAYASHI

Int'l Appl. No.: PCT/JP2004/001116

Int'l Filing Date: February 4, 2004

For: NEUTRON SHIELDING MATERIAL
COMPOSITION, SHIELDING
MATERIAL AND CONTAINER

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Atty. Dkt. No.: MTU.0021US

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INFORMATION DISCLOSURE STATEMENT

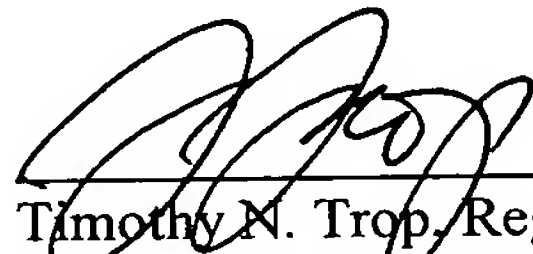
Dear Sir:

Applicant submits the references listed on the attached form PTO 1449 together with any required copies of such references.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 20-1504 (MTU.0021US).

Respectfully submitted,

Date: 8/3/06


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INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				10/588396 IAP11 Rec'd PCT/PTO 03 AUG 2006				
				MTU.0021US				
				PCT/JP2004/001116				
				APPLICANT(S): NORIYA HAYASHI				
FILING DATE: August 3, 2006				GROUP ART UNIT:				
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	A.							
	B.							
	C.							
	D.							
	E.							
U.S. PATENT APPLICATION PUBLICATIONS								
	F.							
	G.							
	H.							
	I.							
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	J.	JP 2003-66189 A1	03/05/2003	JAPAN				X
	K.	JP 6-180389 A1	06/28/1994	JAPAN				X
	L.	EP 0 628 968 A1	10/12/1993	EPO				
	M.	JP 2003-50295 A1	02/21/2003	JAPAN				X
	N.	JP 2004-61463	02/26/2004	JAPAN				X
	O.	JP 6-148388 A1	05/27/1994	JAPAN				X
	P.	JP 60-194394 A1	02/10/1985	JAPAN				X
	Q.	JP 2001-116885 A1	04/27/2001	JAPAN				X
	R.	JP 2001-108787	04/20/2001	JAPAN				X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	S.							
	T.							
	U.							
	V.							
	W.							
EXAMINER				DATE CONSIDERED				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								